

U.S. PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
_	U	"Solid-state thin-film memistor for electronic neural networks", S. Thakoor, A. Moopenn, T. Daud, and A. P. Thakoor, Journal of Applied Physics March 15, 1990 Volume 67, Issue 6, pp. 3132-3135.
	v	"Computational nanotechnology with carbon nanotubes and fullerenes", Srivastava, D. Menon, M. Kyeongjae Cho, NASA Ames Res. Center, Moffett Field, CA, Computing in Science & Engineering, Jul/Aug 2001, Volume 3, Issue 4, pages: 42-55.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

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